

<b>Notice of References Cited</b>	Application/Control No. 10/611,395		Applicant(s)/Patent Under Reexamination RAMANATHAN ET AL.	
	Examiner Heather A. Doty		Art Unit 2813	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0157407	08-2004	Tong et al.	438/455
*	B	US-6,905,945	06-2005	Barmatz et al.	438/455
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al., Silicon Processing for the VLSI Era, Vol. 1, Edition 1, Lattice Press, 1986, pp. 535-536.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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